

# Microfabricated Teflon Membranes for Low-Noise Recordings of Ion Channels in Planar Lipid Bilayers

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**ABSTRACT** We present a straightforward, accessible method for the fabrication of micropores with diameters from 2 to 800  $\mu\text{m}$  in films of amorphous Teflon (Teflon AF). Pores with diameters  $\leq 40 \mu\text{m}$  made it possible to record ion fluxes through ion channels in planar bilayers with excellent signal characteristics. These pores afforded: i), stable measurements at transmembrane voltages up to 460 mV; ii), recordings at low noise levels (0.4 pA rms at 4.3 kHz bandwidth); iii), recordings at high effective bandwidth (10.7 kHz); and iv), formation of multiple planar lipid bilayers in parallel. Microfabricated pores in films of Teflon AF made it possible to examine, experimentally and theoretically, the influence of the pore diameter on the current noise in planar bilayer recordings. Reducing the pore diameter below 40  $\mu\text{m}$  mainly increased the stability of the planar bilayers, but had only a small effect on the level of the current noise. The low-noise properties of bilayer recordings on micropores in Teflon AF films were exploited to record the smallest conductance state of alamethicin (24 pS) at an unprecedentedly high bandwidth of 10.7 kHz.

## INTRODUCTION

Both planar lipid bilayer and patch clamp experiments allow studies of the function of single ion channel proteins. Recordings of planar bilayers and patch clamp preparations provide the most detailed information now available concerning the biophysics of ion channels: they enable the study of single-channel conductance, opening and closing lifetimes, and opening and closing probabilities. Despite the importance of both techniques, the signal and time resolution of patch clamp and, in particular, planar bilayer recordings are limited by electrical current noise. To resolve the gating events of ion channels with small single-channel conductance and fast gating dynamics, it is important to minimize the noise of electrophysiological recordings. Here we present a method to achieve low-noise recordings with planar lipid bilayers.

Planar bilayer experiments have four advantages over patch clamp experiments: i), The composition of the lipid membrane and the surrounding electrolyte can be defined precisely (that compositional definition includes the ability to form asymmetric bilayers). ii), Planar lipid bilayers make it possible to perform electrophysiological studies on ion channels that are difficult to access with patch clamp pipettes, e.g., ion channels in lipid membranes of organelles or bacteria. iii), Both sides of the bilayer can be accessed easily. iv), The technique is relatively easy to use. Planar bilayer experiments also have limitations: i), Their noise

level is usually higher than that in patch clamp recordings. This noise is mainly due to the large capacitance ( $\gg 100$  pF) of most planar bilayers. ii), Planar bilayer experiments are done with artificial lipid membranes in buffer solutions and are thus carried out under nonphysiological conditions. iii), To study ion channels in planar lipid bilayers, the channels have to be reconstituted into the bilayer (Miller, 1986).

Planar lipid bilayer experiments are usually performed with the bilayer supported using polymer sheets with a single pore (Schlue and Hanke, 1993; Wonderlin et al., 1990). Teflon is a well-suited polymer for this application because it is chemically stable, it has good electrical properties (high resistivity, low dielectric constant, and low dielectric loss (Penner, 1995)), and it supports planar lipid bilayers that are stable for several hours (Schlue and Hanke, 1993; Wonderlin et al., 1990). Standard methods to make pores include simple mechanical punching, drilling, or indentation, combined with shaving away material from the opposite side of the sheet until the indentation is intersected (Wonderlin et al., 1990). Pores are also prepared using a high voltage pulse to “burn” holes through thin polymer sheets (Schlue and Hanke, 1993; Wonderlin et al., 1990). It is difficult to generate pores with diameters below 15  $\mu\text{m}$  with these methods (Wonderlin et al., 1990); they also are not easily applied to positioning the pores relative to the supporting membrane, or to generating regular arrays of pores (Pantoja et al., 2001; Peterman et al., 2002). Pore diameters smaller than 15  $\mu\text{m}$  would be desirable to reduce the capacitance across the bilayers, and to enable low-noise recordings. Micrometer-scale control of the position of the pore is required to perform planar lipid bilayer experiments in parallel. Only precisely positioned pores will make it possible to record from multiple bilayers simultaneously and to combine electrical with optical single-molecule detection in an array format (Borisenko et al., 2003; Ide and Yanagida, 1999; Schmidt et al., 2000).

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Silicon microfabrication technology has been used to microfabricate single pores in silicon nitride and silicon dioxide (Fertig et al., 2000; McGeoch et al., 2000; Pantoja et al., 2001; Peterman et al., 2002; Schmidt et al., 2000). Although these septa can be produced with high precision, widespread use of these methods will be limited by the requirement for access to microfabrication facilities to produce them.

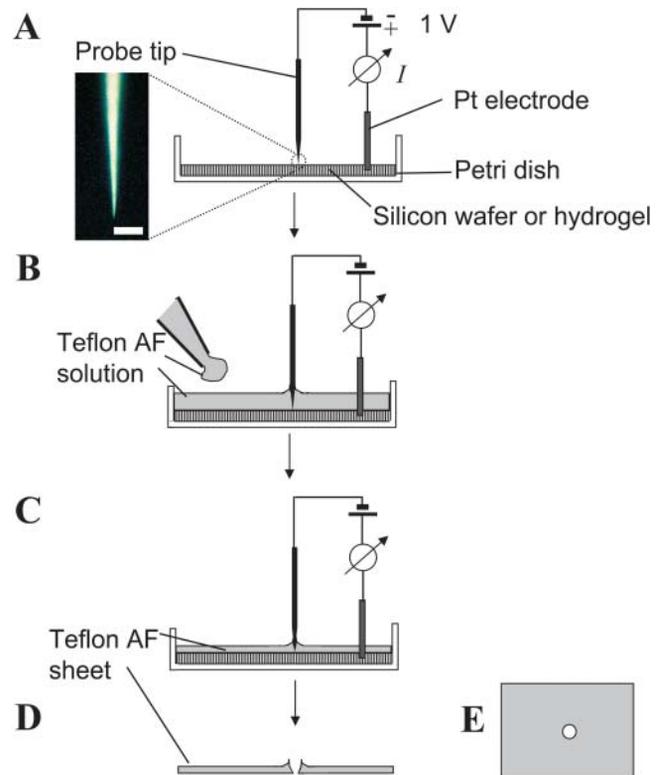
Here we present new, simple methods for the fabrication of micropores based on soft-lithographic methods (micro-molding and casting) (Whitesides et al., 2001; Xia and Whitesides, 1998). Using these methods, fabrication of pores with diameters in the range 2–800  $\mu\text{m}$  can be carried out in a time as short as 4 h, and does not require access to clean rooms or microfabrication facilities. We used amorphous Teflon (Teflon AF) as the material for the septum. This material is comparable to standard Teflon in its chemical robustness, and superior to it in its electrical and optical properties (Makohliso et al., 1998; Resnick and Buck, 1999). We demonstrate the use of micropores in Teflon AF sheets for planar lipid bilayer experiments, and show low-noise, single-channel recordings of ion channels formed by the antibiotic peptide alamethicin (Boheim, 1974; Sakmann and Boheim, 1979). We characterize the stability, electrical resistance, capacitance, and current noise of the bilayers and the supporting Teflon AF septa, and examine experimentally the breakdown voltage and noise of planar lipid bilayers as a function of the pore diameter.

## MATERIALS AND METHODS

### Fabrication of micropores in films of Teflon AF

Fig. 1 summarizes the fabrication of micropores in sheets of Teflon AF (type 1601, 6% in Fluorinert FC-75, DuPont Fluoroproducts, Wilmington, DE) by molding a solution of Teflon AF around a probe with a sharp tip, positioned to be in contact with a silicon wafer or a hydrogel slab. After evaporation of the Fluorinert solvent, the resulting Teflon AF film has a hole at the point of contact between the tip and the wafer or hydrogel. We used commercially available probes from Lucas Signatone (Gliroy, CA) with nominal tip diameters from 0.20 to 125  $\mu\text{m}$  (Lucas Signatone defines the tip diameter as the diameter of the cone at the point where the profile of the cone changes from a steep (cone angle  $6^\circ$ ) to a shallow angle ( $\gg 6^\circ$ )). We used the following probe tips: 125  $\mu\text{m}$  (beryllium copper), 25  $\mu\text{m}$  (tungsten), 10  $\mu\text{m}$  (gold-plated tungsten), 5  $\mu\text{m}$  (tungsten), 3.5  $\mu\text{m}$  (tungsten), 1  $\mu\text{m}$  (tungsten cat whisker), and 0.20  $\mu\text{m}$  (tungsten cat whisker). Before use, we usually immersed the gold-plated tungsten tips (tip diameter 10  $\mu\text{m}$ ) in a fresh solution of  $\sim 5$  mM 1-hexadecanethiol in ethanol over night followed by rinsing with ethanol. This treatment decreased the adhesion of Teflon AF to the tip and resulted in well-defined conical pores. Depending on the mechanical stability of the probe tips, we formed Teflon sheets either on a silicon wafer (Silicon Sense, Nashua, NH) or on an agarose (OmniPur, Merck KGaA, Darmstadt, Germany) gel slab. The silicon wafer was oxidized in an air-plasma, and silanized with tridecafluoro-1,1,2,2-tetrahydrooctyl-1-trichlorosilane (United Chemical Technologies, Bristol, PA), under vacuum ( $\sim 60$  mm Hg). This pretreatment facilitated peeling the Teflon sheets off the wafer after fabrication, and resulted in films with a smoother surface than films made on other substrates (e.g., glass).

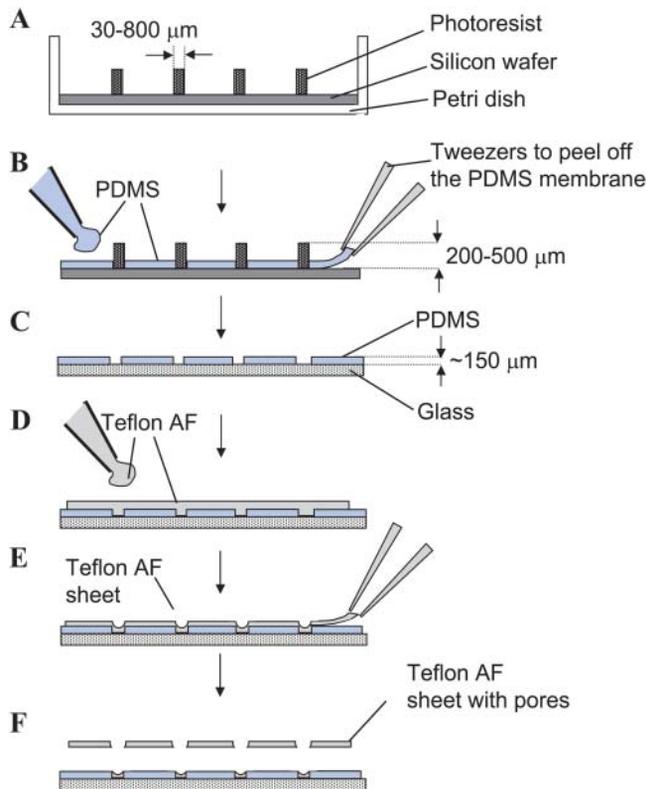
In making pores using mechanically robust tips (tip diameter  $\geq 5$   $\mu\text{m}$ ), we used a silicon wafer as substrate, because it is flat and hard (we wanted to



**FIGURE 1** Microfabrication of pores in Teflon AF sheets. (A) A tip of a sharp probe (e.g., a probe tip) is placed in mechanical or electrical contact with, and oriented perpendicular, to a substrate. Mechanically robust probe tips (tip diameter,  $d_t \geq 5$   $\mu\text{m}$ ) are lowered onto a silicon wafer by their own weight. Fragile tips ( $d_t < 5$   $\mu\text{m}$ ) are lowered onto an agarose gel (1% in 1 M KCl) with a micromanipulator. In the case of fragile tips, contact between the tip and the gel is verified by monitoring the electrical current flowing between the probe tip and a platinum electrode in the hydrogel at a potential of 1 V DC. The optical micrograph shows a probe tip with a nominal diameter of 200 nm (scale bar, 10  $\mu\text{m}$ ). (B) A solution of 6% Teflon AF in Fluorinert FC-75 is added and allowed to mold around the tip. (C) Most of the solvent evaporates within 4 h at room temperature and leaves a sheet of amorphous Teflon behind. (D and E) The resulting Teflon AF sheet (thickness  $\sim 60$   $\mu\text{m}$ ) has a pore at the position of the tip. The opening diameter of the pore is determined by the diameter of the tip and, in the case of preparations using hydrogels as substrates, by its depth of immersion in the hydrogel.

avoid indentation of the substrate by the probe tips). For probe tips with nominal tip diameters below 5  $\mu\text{m}$ , we used hydrogel substrates, because these fragile tips bent on contact with a silicon wafer. To obtain small pore diameters ( $< 5$   $\mu\text{m}$ ) on hydrogel substrates, it was important that the conical tips contacted the gel without deeply penetrating it. We controlled the depth by lowering the probe tips just enough to allow detectable current to flow between the probe tip and a Pt electrode embedded in the hydrogel. Upon contact, the current typically jumped from 0 to  $> 5$  nA (1 V applied potential). Tips with diameters above 5  $\mu\text{m}$  could be lowered gently onto silicon wafers. They did not require electrical verification of contact.

Fig. 2 summarizes an alternative procedure to make micropores with a wide range of diameters (30–800  $\mu\text{m}$ ) in Teflon AF; this procedure also generates arrays of pores. The first fabrication step uses conventional photolithography (Qin et al., 1996) to prepare a master with posts of SU-8 photoresist (MicroLithography Chemical, Newton, MA). Using this master, an unlimited number of poly(dimethylsiloxane) (PDMS) membranes could be made by spin-coating. The actual fabrication of the micropores in Teflon AF was



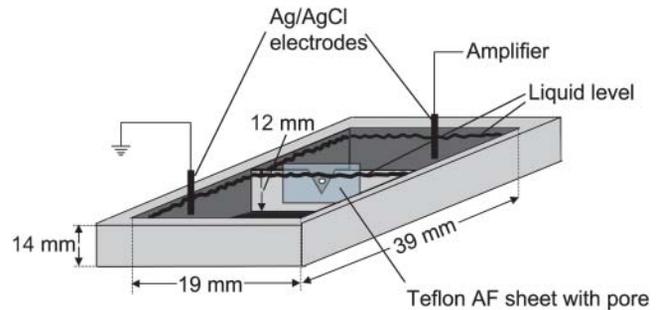
**FIGURE 2** Microfabrication of single pores or arrays of pores in Teflon AF films by spin-coating. (A) The first step involves the fabrication of a master with posts of SU-8 photoresist. Using soft lithography, the diameter of the posts can be varied from 30 to 800  $\mu\text{m}$ . The height of the posts was 200–500  $\mu\text{m}$ . (B) After spin-coating (2000 rpm, 30 s) and curing the PDMS prepolymer on the master, a PDMS membrane with pores is obtained. This membrane is peeled off and (C) placed onto a glass slide. (D) A solution of 9% Teflon AF in a 1:1 mixture of Fluorinert FC-75 and FC-40 (Sigma-Aldrich, St. Louis, MO) is added on top of the supported PDMS membrane and spin-coated at 400 rpm for 30 s. (E) The solvents in the Teflon AF solution are allowed to evaporate at room temperature. (F) Due to its strong adhesion to glass, the Teflon AF in the PDMS wells remains attached to the glass when the Teflon AF film is peeled from the PDMS master; this adhesion results in a membrane with a single pore or with arrays of pores.

carried out on the benchtop, and did not require access to microfabrication facilities. We supported the polydimethylsiloxane (PDMS) membranes containing pores on a glass substrate and spin-coated a Teflon AF solution onto the PDMS. After evaporation of the solvent (for > 24 h at room temperature), we peeled the resulting Teflon AF sheets from the supporting PDMS film; this sheet had pores at the position of the holes in the PDMS films. The PDMS films could be reused after placing them onto a fresh glass slide.

The access resistance of the pores was determined with the experimental system shown in Fig. 3. Access resistance is defined as the sum of several resistances in series, including the resistance of i), the electrolyte in the pore  $R_p$ , ii), the electrolyte converging to the pore (convergence resistance)  $R_c$ , iii), the bulk of the electrolyte  $R_e$ , iv), the electrolyte/electrode interfaces  $R_i$ , and, if employed, v), salt bridges (Wonderlin et al., 1990). We measured the sum of  $R_c$  and  $R_i$  in 1 M KCl using the Teflon chamber without a Teflon AF sheet:  $R_c + R_i = 145 \Omega$ .

### Formation of planar lipid bilayers

Before using the Teflon AF sheets for planar lipid bilayer experiments, we pretreated (Schlue and Hanke, 1993) the area around the pores by sweeping



**FIGURE 3** Planar bilayer setup used for folding lipid monolayers over micropores in Teflon AF sheets to form solvent-free lipid bilayers. The Teflon AF sheets were attached to the chamber with high-vacuum grease (Dow Corning, Midland, MI). After spreading the lipid mixture on the air electrolyte interface, the liquid levels were repeatedly raised above and lowered below the pore until a stable bilayer was obtained.

it about five times with the tip of a tissue paper that had been dipped in a solution of 3–5% squalene (Sigma, St. Louis, MO) in pentane (Sigma-Aldrich, St. Louis, MO) (Tosteson and Chow, 1997). We formed all bilayers from apposition of two monolayers of a 1:1 mixture of *L*- $\alpha$ -phosphatidylserine from brain and 1-palmitoyl-2-oleoyl-*sn*-glycero-3-phosphoethanolamine (both from Avanti Polar Lipids, Alabaster, AL) using the method described by Montal and Mueller (1972). Briefly, we mounted a Teflon AF sheet in a Teflon chamber (Fig. 3) separating two buffer compartments (Alvarez, 1986), each with a volume of 3.5 mL. The lipid mixture (2–10  $\mu\text{L}$  with a concentration of  $\sim 12 \text{ mg mL}^{-1}$  of each lipid) was spread from a solution in pentane onto the surface of the electrolyte solutions (1 M KCl). We formed the bilayers by consecutively raising the liquid level in each compartment until the pore was completely covered by electrolyte. If at this point the pore was not closed by a lipid bilayer, that is, if the seal resistance was  $\ll 1 \text{ G}\Omega$ , then the liquid level in one or both compartments was lowered below the pore by aspirating electrolyte into a 3 mL syringe. Subsequently, the liquid levels were again raised. This cycle was repeated until a high resistance seal ( $> 10 \text{ G}\Omega$ ) was achieved.

The method described above was used for pores that had been prepared by the spin-coating method (Fig. 2). To form lipid bilayers over pores that had been fabricated with the probe-tip method (Fig. 1), we made two modifications. i), After spreading the lipids at the air-electrolyte interface, we raised the liquid levels above the pore on both sides of the Teflon AF film and placed the chamber in a vacuum ( $\sim 60 \text{ mm Hg}$ ) for 5 min (while stirring each compartment) to remove air bubbles that might be trapped in the pores. ii), We lowered and raised the liquid level only in the compartment of the Teflon chamber that faced the flat side of the Teflon AF film (the side that faced the wafer or hydrogel during fabrication). By preparing the bilayer from this side, we were sure that it was formed at the position where the cone-shaped pore had its smallest diameter.

To explore if planar lipid bilayers could also be formed on films of Teflon AF by the “painting technique” (Mueller et al., 1962), we pretreated the area around the pore with 1  $\mu\text{L}$  of a solution of 5  $\text{mg mL}^{-1}$  aolectin (Fluka) in pentane before mounting the film into the chamber (Fig. 3). After filling both compartments with 3.5 mL of 1 M KCl, we applied a solution of 30  $\text{mg mL}^{-1}$  aolectin in *n*-decane (Fluka) with a paintbrush.

### Electrophysiological recordings, filter settings, and noise bandwidth

All recordings were performed in the capacitive feedback configuration of the Axopatch 200B amplifier (Axon Instruments, Union City, CA) and the data were filtered with the built-in four-pole Bessel filter with a cutoff frequency ( $-3 \text{ dB}$  frequency) of  $f_{c1} = 10 \text{ kHz}$ . The sampling rate of the data

acquisition system (Digidata 1322A, Axon Instruments) was 50 or 100 kHz (according to sampling theory, the sampling rate should be at least four times higher than the cutoff frequency of the filter). When no additional filter was used, the overall cutoff frequency  $f_c'$  was equal to  $f_{c1}$ ; most data were, however, also filtered digitally with the Gaussian filter of the pClamp software (Axon Instruments). The overall cutoff frequency  $f_c'$  for filter combinations was estimated using Eq. 1 (Benndorf, 1995; Sherman-Gold, 1993):

$$f_c' = \sqrt{\frac{1}{\frac{1}{f_{c1}^2} + \frac{1}{f_{c2}^2} + \frac{1}{f_{c3}^2} + \frac{1}{f_{c4}^2}}} \quad (1)$$

We first filtered with a cutoff frequency  $f_{c2} = 10$  kHz; this filter combination resulted in an overall cutoff frequency  $f_c' = 7071$  Hz. If we wanted to reduce the noise levels further, we filtered the data further with a cutoff frequency of  $f_{c3} = 5$  kHz (resulting in an overall cutoff frequency  $f_c' = 4082$  Hz) and  $f_{c4} = 1$  kHz (overall cutoff frequency  $f_c' = 971$  Hz). To compare the values of the experimentally determined current noise with theoretically estimated noise levels, we converted the overall cutoff frequency  $f_c'$  of the employed filter combinations to the overall theoretical bandwidth of the current noise  $B_{th}$ . A precise conversion is, however, complicated for filter combinations. Here we approximated  $B_{th}$  by applying the conversion factor for a Gaussian filter (Blinchikoff and Zverev, 1976) to the overall cutoff frequency:  $B_{th} = 1.065 \times f_c'$ . This estimation yielded the following values for the overall theoretical bandwidth of the noise of the four filter combinations used in this work:  $B_{th1} = 10650$  Hz,  $B_{th2} = 7531$  Hz,  $B_{th3} = 4347$  Hz, and  $B_{th4} = 1034$  Hz. Since the overall theoretical noise bandwidth  $B_{th}$  was used as a fitting parameter in this work, we also used an experimental method to estimate  $B_{th}$  for all four filter combinations. We recorded the current noise with a cutoff frequency of 100 kHz of the four-pole Bessel filter of the amplifier (sampling rate 500 kHz) and used the pClamp software to obtain the power spectrum of the noise trace. We then recorded the current noise under the same conditions but with a cutoff frequency of the four-pole Bessel filter of  $f_{c1} = 10$  kHz and computed the power spectrum from this trace. Power spectra were also computed for the same noise trace after filtering it with the other filter combinations ( $f_{c2}$ – $f_{c4}$ ) used in this work. Each power spectrum that was obtained for the cutoff frequencies  $f_{c1}$ – $f_{c4}$  was then divided by the power spectrum that was obtained for the cutoff frequency of 100 kHz. The integrals under the resulting four functions yielded an estimate of the noise bandwidth  $B_{th}$  of the filter combinations used in this work. We obtained the following values for  $B_{th}$ : 10785, 7404, 4459, and 1047. These values are close to the theoretically estimated values  $B_{th1}$ – $B_{th4}$  described above (deviation  $\leq 2.6\%$ ). Throughout this work we used the values for  $B_{th1}$ – $B_{th4}$  for the analysis of the current noise.

## RESULTS AND DISCUSSION

### Microfabrication and access resistance of pores in Teflon AF

Fig. 4 shows pores with various diameters in sheets of Teflon AF. The “probe-tip method” resulted in Teflon sheets with a thickness of  $\sim 60 \mu\text{m}$  when their fabrication was carried out using wafers, and  $\sim 30 \mu\text{m}$  using hydrogels. The pores had diameters from 2 to  $230 \mu\text{m}$ , and had a conical shape replicating the taper of the tips. Conical pores are well suited for bilayer experiments because they make it possible to fabricate small opening diameters in relatively thick sheets without the disadvantage of a high electrical access resistance  $R_a$  of the pores (Wonderlin et al., 1990). Thick sheets ( $>20 \mu\text{m}$ ) are desirable because they contribute

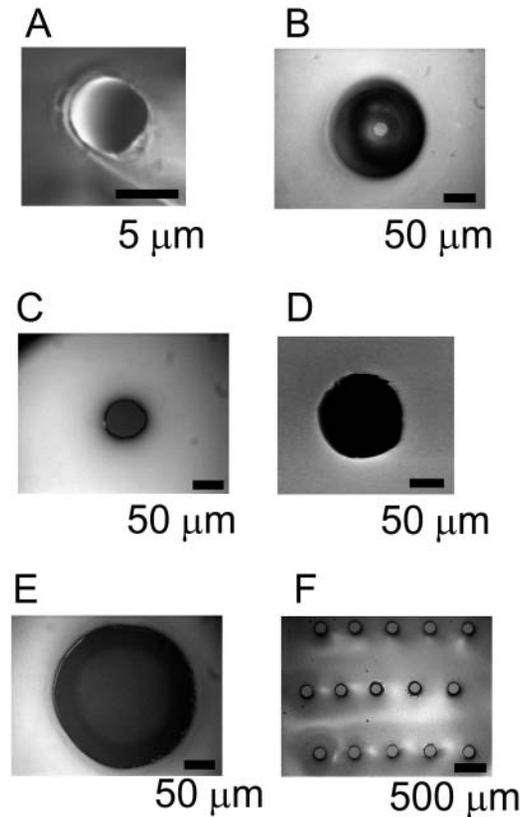


FIGURE 4 Micrographs of pores in Teflon AF films. (A) SEM image of a pore, fabricated with the probe tip method described in Fig. 1 using an agarose gel as substrate and a probe tip (tungsten cat whisker) with a nominal diameter of 200 nm. (B) A micropore fabricated on a silicon wafer with a gold-plated tungsten probe tip with a nominal diameter of 10  $\mu\text{m}$ . The dark region is caused by the tapered shape of the pore. The actual opening diameter of the pore can be seen in the center of the dark region. (C–E) Micropores fabricated by spin-coating a Teflon AF solution over a supported PDMS film with pores as described in Fig. 2. The following pore diameters in the PDMS film were used: (C) 50  $\mu\text{m}$ , (D) 110  $\mu\text{m}$ , and (E) 220  $\mu\text{m}$ . (F) Array of micropores fabricated with the method described in Fig. 2. The diameter of the pores in PDMS was 150  $\mu\text{m}$ .

a smaller capacitance than thinner films, and because they are mechanically robust. Small pore opening diameters are good because they facilitate the formation of planar bilayers with the folding technique, and because they minimize bilayer capacitance. The advantage of a small access resistance is reduced electrical current noise (Wonderlin et al., 1990).

The access resistance  $R_a$  of the conical pores fabricated with the probe-tip method could be described well ( $r^2 = 0.98$ ,  $n = 10$ ) using Eq. 2. We derived this equation by integrating the resistance of the electrolyte over the length of a conical pore (Sakmann and Neher, 1995).

$$R_a = \frac{4\rho l_p}{2\pi l_p \tan(\frac{\Theta}{2})d_p + \pi d_p^2} + \frac{\rho}{2d_p} + R_e + R_i. \quad (2)$$

Here,  $\rho = 0.1134 \Omega\text{m}$  represents the specific resistance of the 1 M KCl solution,  $l_p$  (m) the length of the pore,  $\Theta$  the cone angle of the tip,  $d_p$  (m) the opening diameter of the pore,  $R_e$

the resistance of the bulk of the electrolyte solution, and  $R_i$  the resistance of the electrolyte/electrode interfaces ( $R_e + R_i = 145 \Omega$  in 1 M KCl). The second term in Eq. 2 accounts for the convergence resistance to the pore—that is the resistance of the electrolyte converging from the bulk of the solution to the entrance of the pore at the flat side of the film (Wonderlin et al., 1990).

As indicated schematically in Fig. 1, the Teflon AF solution formed a meniscus around the probe tips, which, after evaporation of the solvent, resulted in a rim (height 40–500  $\mu\text{m}$ ) of Teflon around the pore on the side of the Teflon AF sheet, opposite to the wafer or hydrogel. Because of the conical shape of the pore, this rim did not significantly increase the access resistance, and we did not notice an effect from it on the noise levels of experiments carried out with planar bilayers.

The opening diameter of the pores in Teflon AF depended on the diameter of the probe tips that were used for the fabrication. For fabrication on a hard substrate (a wafer), the diameter of the pore was typically a factor of 1.3–2.5 larger than the diameter of the probe tips; e.g., in the case of probe tips with a diameter of 10  $\mu\text{m}$ , the pores had a diameter of  $18 \pm 3 \mu\text{m}$  ( $n = 5$ ). Fabrication on hydrogel substrates typically resulted in pores with diameters from 2 to 8  $\mu\text{m}$  when a probe tip with a diameter of 200 nm was used.

Fig. 4 also shows pores in Teflon AF sheets, which were fabricated by the spin-coating method outlined in Fig. 2. This method was particularly useful for the fabrication of arrays of pores in Teflon AF. Since the position, shape, and diameter of the pores in Teflon AF were determined by the microfabricated PDMS membrane that was used for their fabrication, the spin-coating method made it possible to fabricate pores, and arrays of pores, of any desired geometry and diameter. The thickness of the Teflon sheets depended on the angular velocity of the spinner used in spin-coating: with 9% Teflon AF solutions and 30 s spin time, the thickness of the dry Teflon sheets was 38  $\mu\text{m}$  for 300 rpm, 32  $\mu\text{m}$  for 400 rpm, 26  $\mu\text{m}$  for 500 rpm, and 15  $\mu\text{m}$  for 1000 rpm spin speed. The area around the pore was somewhat tapered and therefore thinner than the rest of the sheet.

The spin-coating method resulted in pores with diameters that were 1.0–1.2 that of the diameter of the hole in the PDMS film. For pore diameters from 43 to 615  $\mu\text{m}$ , the access resistance  $R_a$  of these pores was described well ( $r^2 = 0.96$ ,  $n = 7$ ) by the convergence resistance at both sides of the pore and the sum of  $R_e$  and  $R_i$ :

$$R_a = \frac{\rho}{d_p} + R_e + R_i. \quad (3)$$

### Properties of planar bilayers as a function of their diameter

We tested Teflon AF sheets containing pores that were made by the probe-tip method and by the spin-coating method for

use for planar bilayer experiments. Bilayers formed readily when the Teflon AF membranes were pretreated with squalene: After spreading the lipids on the air-electrolyte interface, we usually obtained stable bilayers within the first two to five cycles of raising and lowering the liquid levels. It was more difficult, but nonetheless possible, to obtain bilayers when the membranes were pretreated with hexadecane or decane instead of squalene.

We were also successful in forming bilayers on films of Teflon AF by the painting technique (Mueller et al., 1962; White, 1986). The typical thinning of the decane/lipid droplet to a bilayer with high resistance was, however, only observed with pore diameters  $\geq 70 \mu\text{m}$ . Throughout this work we used the folding technique (Fig. 3) for the formation of planar lipid bilayers.

The seal resistance of the bilayers increased with decreasing pore diameter: with pore sizes from 2 to 130  $\mu\text{m}$ , the resistance ranged from 49 to  $\sim 660 \text{ G}\Omega$  (mean: 258  $\text{G}\Omega$ ,  $n = 25$ ) and with pore sizes from 230 to 800  $\mu\text{m}$ , the resistance was 24–141  $\text{G}\Omega$  (mean: 62  $\text{G}\Omega$ ,  $n = 11$ ). We evaluated the resistance of Teflon AF sheets without holes, and found a value of  $>10^{12} \Omega$  for a thickness of  $\sim 60 \mu\text{m}$ . The Teflon AF sheets were therefore considered insulating in the context of this work.

Most bilayers were stable for at least 1 h at voltages of  $\pm 150 \text{ mV}$ . Bilayers that were left undisturbed at potentials  $\leq |100 \text{ mV}|$  frequently lasted for more than 5 h before breakdown. Fig. 5 shows the dependence of the breakdown voltage of the bilayers on the pore diameter. With the 2  $\mu\text{m}$  diameter pore, we were able to perform alamethicin recordings at up to 460 mV. Breakdown voltages higher than 300 mV were observed frequently ( $>50\%$ ) for pore diameters below 50  $\mu\text{m}$ . High breakdown voltages are clearly

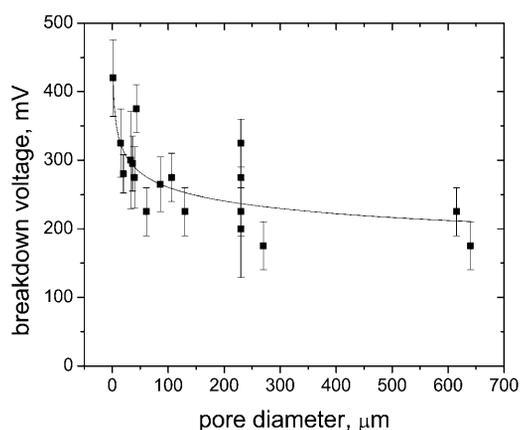


FIGURE 5 Breakdown voltage of planar bilayers on Teflon AF membranes as a function of the pore diameter. Breakdown voltage was defined as the minimum voltage (applied for  $\geq 5$  min) required to break a bilayer irreversibly or disturb it such that an abrupt increase in current noise was observed. The error bars represent the standard deviation of the breakdown voltages of at least three repetitions. The line represents the best fit:  $y = 422 \times x^{-0.115}$ .

beneficial for studying ion channels with small single-channel conductance (Peterman et al., 2002). Using comparable pore diameters, we found no difference in the stability of the pores made by the probe-tip and the spin-coating methods. For comparison, we also determined the breakdown voltage of a 60  $\mu\text{m}$  pore that had been burned into a standard PTFE Teflon foil with a high voltage pulse (Tosteson and Chow, 1997) and found that the bilayers broke down electrically at potentials between 200 and 250 mV; the corresponding value for pores in Teflon AF was 250–300 mV.

The increase in membrane capacitance  $C_m$  (F) with pore diameter  $d_p$  of bilayers formed after squalene pretreatment is described by Eq. 4:

$$C_m = C_s \frac{\pi}{4} d_p^2. \quad (4)$$

Here  $C_s$  is the specific capacitance (Reyes and Latorre, 1979; Waldbillig and Szabo, 1979; White and Thompson, 1973). Our experimental data were fitted best ( $r^2 = 0.92$ ,  $n = 13$ ) with  $C_s = 9.63 \times 10^{-3} \text{ F m}^{-2}$  ( $0.963 \mu\text{F cm}^{-2}$ ). The total capacitance  $C_t$  (F) is given by Eq. 5,

$$C_t = C_m + C_{se} + C_{el}, \quad (5)$$

where  $C_{se} = 9 \times 10^{-12} \text{ F}$  was the capacitive contribution of the Teflon AF sheets, and  $C_{el} = 10 \times 10^{-12} \text{ F}$  was the capacitance of the immersed electrodes.

### Preparation of planar lipid bilayers over multiple pores

The procedure outlined in Fig. 2 makes it possible to prepare Teflon AF films with multiple pores. We used a Teflon film with three pores of equal diameter (120  $\mu\text{m}$ ) to test the possibility of forming multiple planar bilayers in parallel. The Teflon AF film was mounted into the experimental system (Fig. 3) such that the three pores were oriented in a vertical line. Employing the same protocol as used for single pores, we were able to form three bilayers in parallel. The capacitance increased stepwise while the liquid level of the electrolyte was raised over one, two, and three pores. The total capacitance was 328 pF, corresponding well to the theoretical capacitance (Eq. 4) of 327 pF of three planar bilayers with a diameter of 120  $\mu\text{m}$ . The bilayers were stable for at least 1 h.

### Analysis of the current noise as a function of the pore diameter

The electrical current noise is an important aspect of planar bilayer experiments. Noise can be characterized by its power spectral density or by its variance (which is the integral of the spectral density over the frequency range  $f = 0-B$ , where  $B$  represents the bandwidth). The spectral density of the noise ( $S^2$  in  $\text{A}^2 \text{ Hz}^{-1}$ ) and the noise variance ( $i^2$  in  $\text{A}^2$ ) in planar

bilayer recordings have contributions from four sources of noise. The first is the noise resulting from the interaction of the headstage input voltage noise and the input capacitance, described by Eqs. 6 (power spectral density) and 7 (noise variance) (Wonderlin et al., 1990) (“headstage” refers to the amplifier, which is placed as close as possible to the recording electrodes. It amplifies small currents into values sufficient for the main amplifier to accept):

$$S_{vc}^2 = 4e_n^2 \pi^2 C_t^2 f^2 \quad (6)$$

$$i_{vc}^2 = \frac{4}{3} e_n^2 \pi^2 C_t^2 B^3. \quad (7)$$

Here  $e_n$  is the root mean-square (rms) noise voltage in the headstage input. We used a value of  $e_n = 2.3 \times 10^{-9} \text{ V Hz}^{-0.5}$  (Rae and Levis, 1984; Sherman-Gold, 1993).  $C_t$  is the total input capacitance,  $f$  (Hz) is the frequency, and  $B$  (Hz) is the bandwidth. The second contribution to noise is the thermal voltage noise of the access resistance  $R_a$  in series with the bilayer capacitance  $C_m$  (Eqs. 8 and 9) (Wonderlin et al., 1990),

$$S_{rc}^2 = 4kT \frac{4\pi^2 f^2 R_a^2 C_m^2}{R_a (1 + 4\pi^2 f^2 R_a^2 C_m^2)} \quad (8)$$

$$i_{rc}^2 = \frac{4kT}{R_a} \left( B - \frac{\arctan(2\pi R_a C_m B)}{2\pi R_a C_m} \right), \quad (9)$$

where  $k$  is the Boltzmann constant ( $k = 1.38 \times 10^{-23} \text{ J K}^{-1}$ ) and  $T$  is the absolute temperature (K). The third noise source in planar bilayer experiments is the dielectric noise. It results from thermal fluctuations in lossy dielectric materials with a capacitance  $C_t$  (Eqs. 10 and 11) (Levis and Rae, 1998).

$$S_d^2 = 8kT \pi D C_t f \quad (10)$$

$$i_d^2 = 4kT \pi D C_t B^2. \quad (11)$$

Here the dielectric loss factor (also called dissipation factor)  $D$  (unitless) is composed of the loss factors of all dielectric materials that contribute to the capacitance  $C_t$ . Not all materials that contribute to  $C_t$  contribute to  $D$  to the same extent. It is thus complicated to evaluate the precise value of the overall  $D$ . The biggest contribution is, however, expected from the septum (K. Benndorf, personal communication); the contribution from the lipid bilayer is predicted to be small (Lauger, 1979).  $D$  can be considered constant in the important bandwidth range between 1 and 100 kHz (Sherman-Gold, 1993). The dielectric loss factor of Teflon AF is very low,  $D = 8.0 \times 10^{-5} - 2.0 \times 10^{-4}$ , and Teflon AF has the lowest known dielectric constant of any solid, uniform plastic material ( $\epsilon = 1.89-1.93$ ) (Resnick and Buck, 1997, 1999); both properties minimize the dielectric noise.

In the context of planar bilayer recordings, noise sources such as shot noise, Johnson noise and  $1/f$  noise are small compared to the three noise sources discussed above

(Wonderlin et al., 1990). We summarized all noise sources apart from the ones described by Eqs. 6–11 as “excess noise”  $i_e$ . Due to the random nature of the individual noise sources, the total root mean-square value of the current noise can be calculated using Eq. 12 (Sherman-Gold, 1993):

$$i_t = \sqrt{i_{vc}^2 + i_{rc}^2 + i_d^2 + i_e^2}. \quad (12)$$

The total rms current noise can be determined experimentally. It is defined as the standard deviation of the current from its mean value.

Equations 5–12 indicate that the noise in planar bilayer experiments depends on the recording bandwidth, the bilayer capacitance, and the access resistance of the pore.

Since the recording bandwidth has to be adjusted to the single-channel conductance and kinetics of the ion channel under investigation, it can only be minimized to a certain degree. If high bandwidth is required, the most accessible experimental parameters that can be optimized to achieve low noise are the access resistance and the total capacitance. Both parameters depend on the pore diameter. The fabrication methods presented here allow the preparation of micropores with a wide range of diameters; this capability, in principle, makes it possible to optimize the pore diameter for specific applications.

We examined the rms current noise as a function of the pore diameter. Fig. 6 shows the rms current noise as a function of the pore diameter measured with lipid bilayers on Teflon AF membranes that had been prepared by the spin-coating method. The data were fitted with Eq. 13—a modified form of Eq. 12, containing factors that account for the nonideal behavior of low-pass filters (Benndorf,

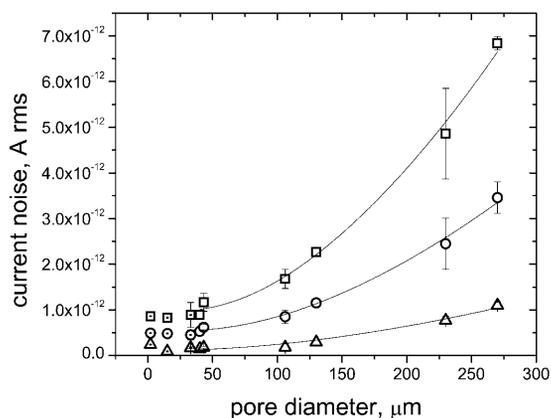


FIGURE 6 Total rms current noise as a function of the pore diameter. The noise levels were recorded at three different values of the overall bandwidth of the noise  $B_{th}$ : 7531 Hz ( $\square$ ), 4347 Hz ( $\circ$ ), and 1034 Hz ( $\triangle$ ). The lines represent the best curve fits using Eqs. 3–13 and a dielectric loss factor of  $D = 2 \times 10^{-4}$ . Error bars represent the standard deviation of the noise levels recorded with different Teflon AF films, which had approximately the same pore diameters. The results of the curve fits are summarized in Table 1. Data with a dot in the symbol were obtained with pores that had been fabricated with the probe-tip method. These data were not included in the curve fits.

1995; Levis and Rae, 1998). Since we do not know the precise correction factors for the digital Gaussian filter, we used the correction factors for an eight-pole Bessel filter (the characteristics of Bessel filters with increasing numbers of poles approach the characteristics of Gaussian filters (Lindquist, 1977)). The correction factors are determined by the frequency dependence of the spectral density of the noise: for flat noise the factor is  $\sim 1.04$ , for  $f$ -noise it is  $\sim 1.3$ , and for  $f^2$ -noise it is  $\sim 2.0$  (Benndorf, 1995; Levis and Rae, 1998). The corrected version of Eq. 12 is therefore:

$$i_t = \sqrt{2.0i_{vc}^2 + 2.0i_{rc}^2 + 1.3i_d^2 + 1.3i_e^2}. \quad (13)$$

The correction factor of 1.3 for the noise variance of the excess current noise  $i_e$  was inferred from the curve fits in Fig. 6. We observed that  $i_e$  was proportional to the bandwidth (Table 1); the spectral density of the excess noise  $S_e^2$  was therefore linearly dependent on  $f$ . Thus in the range of bandwidth examined here (1034–7531 Hz), the excess current noise was of the  $f$ -noise type.

In Fig. 6, we plotted the total rms current noise that was obtained at three different values of the overall theoretical bandwidth of the noise  $B_{th}$  as a function of the pore diameter. Only noise values that were measured with pores made by the spin-coating method were included in this analysis. Fig. 6 shows the best fits of the data by curves calculated using Eq. 13; these curves were obtained by assuming a dielectric loss factor of  $D = 2 \times 10^{-4}$  for Teflon AF. The fitting parameters were the excess current noise  $i_e$ , which was assumed to be independent of the pore diameter, and the bandwidth  $B$ . Table 1 summarizes the fitting parameters.

Fig. 6 and the values for  $r^2$  in Table 1 establish that the experimental current noise can be described well with Eq. 13. The bandwidths determined from the curve fits are also close to the values of the theoretically estimated bandwidth of the noise  $B_{th}$ . We found, however, a deviation at the lowest bandwidth: the data were fitted best with  $B = 2187$  Hz, although the estimated value of  $B_{th}$  was 1034 Hz. It seems that at lower frequencies, additional sources of noise, which are dependent on the pore diameter, become important for the overall noise. Since these additional sources appeared to be less important at  $B_{th}$  values  $\geq 4347$  Hz, we used only the data recorded at  $B_{th} = 4347$  and 7531 Hz for further analyses.

TABLE 1 Fitting parameters ( $B$ ,  $i_e$ , and  $r^2$ ) obtained from best curve fits of the measured total rms current noise at three different values of the noise bandwidth  $B_{th}$

$B_{th}$ (Hz)	$B$ (Hz)	$i_e$ (A rms)	$r^2$
1034	2187	$9.8 \times 10^{-14}$	0.98
4347	4769	$4.5 \times 10^{-13}$	0.99
7531	7554	$8.1 \times 10^{-13}$	0.99

We used Eqs. 3–13 and a value of  $D = 2 \times 10^{-4}$  for the curve fits.

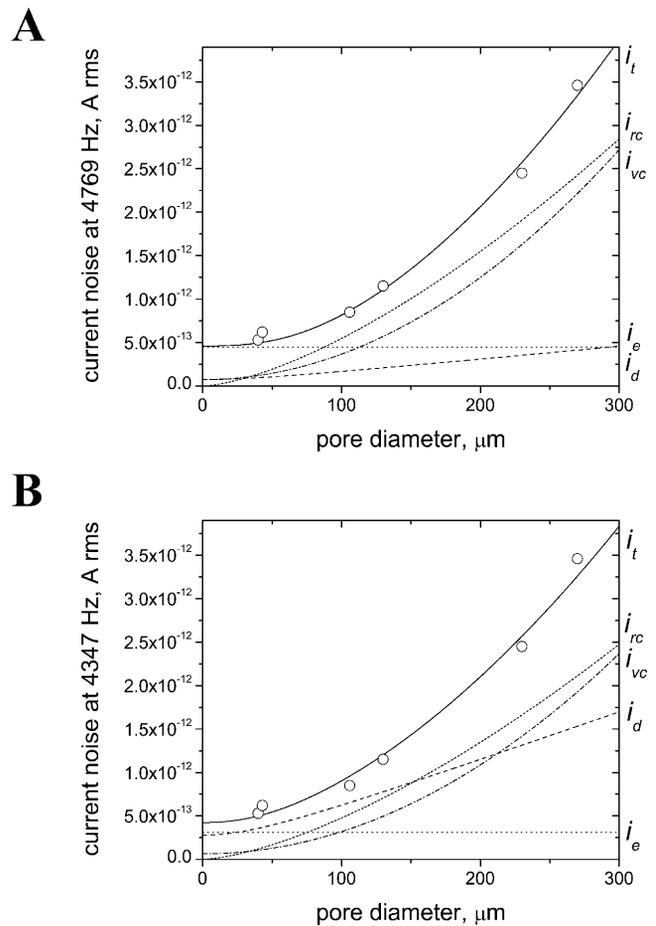
**TABLE 2** Fitting parameters obtained from best curve fits of the measured total rms current noise with Eqs. 3–13 and  $B = B_{th}$ 

$B_{th}$ (Hz)	$B$ (Hz)	$D$	$i_e$ (A rms)	$r^2$
1034	1034	$1.8 \times 10^{-2}$	$1.1 \times 10^{-19}$	0.88
4347	4347	$3.3 \times 10^{-3}$	$3.1 \times 10^{-13}$	0.99
7531	7531	$2.4 \times 10^{-4}$	$8.2 \times 10^{-13}$	0.99

To estimate the dielectric loss factor  $D$ , we fitted the experimental data in Fig. 6 with Eq. 13 by setting the bandwidth fixed to  $B_{th}$  and by varying  $D$ . The results of the best curve fits are summarized in Table 2. As expected, the curve fit for the data recorded at  $B_{th} = 1034$  Hz was poor. For the higher values of  $B_{th}$ , however, the fits were good; this agreement indicates that the overall dielectric loss factor was in between the value for Teflon AF ( $D = 2 \times 10^{-4}$ ) and  $D \sim 3 \times 10^{-3}$ .

To minimize the overall noise in planar bilayer experiments, it is helpful to examine the importance of the individual noise sources. Before discussing the data, however, we point out that since the individual noise sources add in an rms fashion (Eq. 13), the largest individual source of noise tends to dominate the total noise (Levis and Rae, 1998). Fig. 7 A shows the contribution of each source of noise to the experimentally measured total rms current noise as a function of the pore diameter. The curve was calculated with a bandwidth of 4347 Hz and a dielectric loss factor of  $D = 2 \times 10^{-4}$ . Up to a pore diameter of  $\sim 25 \mu\text{m}$ , the overall rms current noise  $i_t$  is dominated by the excess noise  $i_e$ . As mentioned earlier, in the approach taken here,  $i_e$  includes the shot noise, Johnson noise, and  $1/f$  noise. At  $\sim 100 \mu\text{m}$  pore diameter,  $i_e$ ,  $i_{vc}$ , and  $i_{rc}$  contribute about equally to the overall rms current noise. With further increasing pore diameters, the contributions of  $i_{rc}$  and  $i_{vc}$  become more and more important and dominate the overall current noise. In the example represented in Fig. 7 A, the contribution of the dielectric noise  $i_d$  to the overall current noise was small ( $i_d^2 < 0.04 \times i_t^2$ , for all diameters).

The importance of the dielectric noise increases, however, with an increasing dielectric loss factor  $D$ . As mentioned before, the septum contributes to the overall dielectric loss factor, but so do other materials in the vicinity of the headstage. Table 2 lists the estimated overall values of  $D$  as obtained from the best curve fits of the total rms current noise to the current noise recorded at three values of  $B_{th}$ . The highest value of  $D = 1.8 \times 10^{-2}$  is unlikely since it is impossible to obtain good curve fits for the data recorded at a higher cutoff frequency than  $B_{th} = 1034$  Hz. Fig. 7 B shows the best fit of the total rms current noise at 4347 Hz assuming an overall loss factor of  $D = 3.3 \times 10^{-3}$ . Under these conditions, the dielectric noise represents the largest contribution to the total noise for pore diameters between 25 and 160  $\mu\text{m}$ . Wonderlin et al. (1990) reported that the rms current noise increased by a factor of 1.5 when nylon instead of Teflon was used for bilayer experiments. The dielectric



**FIGURE 7** Individual sources of noise as obtained by the best curve fits of the total rms current noise  $i_t$  for different values of the bandwidth  $B$  and the dielectric loss factor  $D$ . (A) Individual noise sources  $i_{rc}$ ,  $i_{vc}$ ,  $i_e$ ,  $i_d$ , and total rms current noise  $i_t$  obtained by the best curve fit to the noise measured with  $B_{th} = 4347$  Hz. The fitting parameters were the bandwidth  $B$  and the excess current noise  $i_e$ ; the dielectric loss factor was assumed to be  $D = 2 \times 10^{-4}$ . The best curve fit was obtained with  $B = 4769$  Hz and  $i_e = 0.45$  pA rms. (B) Individual noise sources and total rms current noise obtained by the best curve fit with the dielectric loss factor  $D$  as the fitting parameter and setting the bandwidth  $B$  to  $B_{th} = 4347$  Hz. The best curve fit was obtained with  $D = 3.3 \times 10^{-3}$  and  $i_e = 0.31$  pA rms.

loss of nylon is  $\sim 1.5 \times 10^{-2}$  (Pflueger, 1989), compared to  $\leq 2 \times 10^{-4}$  for Teflon AF. Due to its low dielectric loss factor, Teflon AF is an excellent material to use in minimizing the dielectric noise.

Fig. 7 illustrates that with our experimental setup and protocol, the rms current noise is dominated by the excess noise  $i_e$ , when the pore diameter is smaller than 25  $\mu\text{m}$ . A reduction of the pore diameter below 25  $\mu\text{m}$  will therefore not result in a significant reduction of the overall noise. This result is in agreement with the work from Fertig et al. (2001), in which a glass chip with a small pore ( $d_p = 2 \mu\text{m}$ ) was used for planar bilayer recordings. The authors report an overall rms current noise of 0.32 pA rms at a bandwidth of  $\sim 3$  kHz and  $\sim 0.1$  pA rms at  $\sim 1$  kHz; these values compare well to

our noise of 0.46 pA rms at 4.35 kHz, and 0.09 pA rms at 1.03 kHz. It follows that a further reduction in the noise of planar bilayer recordings can only be achieved if the excess noise is minimized. From patch clamp experiments, it is known that noise levels as low as 0.083 pA rms at a bandwidth of 5 kHz can be achieved (Rae and Levis, 1992).

To understand better why the excess noise in planar bilayer experiments is higher than in patch clamp experiments, we measured the noise of the amplifier under different experimental conditions. The noise of the shielded headstage was 0.044 pA rms ( $B \cong 5.1$  kHz). Connecting Ag/AgCl wire electrodes to the headstage and ground, but leaving both electrodes in air, yielded a noise of 0.07 pA rms ( $B_{th} = 4347$  Hz). When both electrodes were immersed in 1 M KCl in separate glass vials with an air gap between the vials, the noise was 0.43 pA rms ( $B_{th} = 4347$  Hz). Finally, with both electrodes in 1 M KCl in the planar bilayer setup and a spin-coated Teflon AF membrane without a hole between the compartments, the noise was  $0.44 \pm 0.08$  pA rms ( $B_{th} = 4347$  Hz). The total noise  $i_t$  recorded with the setup used in this work (Fig. 3) was dependent on the input capacitance  $C_t$ . At a bandwidth of 4082 Hz, we found a linear relationship between the rms current noise and the capacitance in the range of 10–28 pF. The slope was 0.012 pA rms/pF and the y-intercept was 0.15 pA rms ( $r = 0.99$ ,  $n = 5$ ). The y-intercept can be used as an approximation of the minimum noise that could be achieved with the experimental setup and protocol used here, if the input capacitance could be reduced to  $<1$  pF. An rms current noise of 150 fA is about twice the value that can be achieved with the best low-noise patch clamp setups. To reach such low noise levels, the capacitance of the setup would have to be reduced to  $<1$  pF (in our case, the electrodes in electrolyte contribute 10 pF and the Teflon AF septa contribute  $\sim 9$  pF) and the complete setup would have to be rigorously optimized for low-noise characteristics. The pores would have to be  $\leq 10$   $\mu\text{m}$  in diameter; these sizes would result in a membrane capacitance of  $C_m \leq 0.75$  pF. Further optimization might involve improved grounding, shielding, and vibration damping, as well as frequent formation of fresh silver chloride on the Ag/AgCl electrodes.

Although our minimum noise levels of  $\sim 0.4$  pA rms at 4.35 kHz bandwidth are high compared to patch clamp experiments, they are very low compared to most bilayer experiments. To test the performance of the Teflon AF septa, and to make use of the low-noise characteristics, we recorded single-channel current traces of alamethicin ion channels.

### Low-noise single-channel recordings of alamethicin pores

Alamethicin, an antibiotic peptide containing 20 amino acids, self-integrates into bilayers and forms voltage-gated ion channels of defined conductance by oligomerization

(Boheim et al., 1983; Fox and Richards, 1982). We added alamethicin to both chambers to a final concentration of 10 ng mL<sup>-1</sup>. After  $\sim 10$  min, we recorded typical voltage-gated activation of alamethicin channels: at potentials  $<|60$  mV|, no events were observed. At higher voltages, we saw single-channel events with current amplitudes that increased with increasing potential. Fig. 8 shows single-channel alamethicin events recorded at  $-202$  mV, and the point-amplitude histogram derived from the single-channel current. The single-channel conductance values of open states  $O_1$ – $O_6$  were: 24, 395, 1375, 2662, 3989, and 5430 pS. These values compare well to previously reported conductance values of 19, 280, 1300, 2700, 4400, and 6200 pS in 1 M KCl (Hanke and Boheim, 1980). Fig. 8 C and the corresponding point-amplitude histogram show the lowest conductance state  $O_1$  of alamethicin. We were able to resolve  $O_1$  at an unprecedentedly high bandwidth of  $B_{th} = 10,650$  Hz. This result demonstrates that the microfabricated Teflon AF septa employed in this work make it possible to resolve small ion channel events at high bandwidth.

Fig. 8 C also illustrates that the transition of alamethicin channels from one conductance state to the next higher or lower state is very rapid. We made use of this characteristic to evaluate the effective cutoff frequency  $f_c''$  of our recordings under “real” recording conditions. Using only the built-in four-pole Bessel filter with a cutoff frequency of 10 kHz, we found that it took 28.5  $\mu\text{s}$  for alamethicin channels to change from one conductance state to the next (more precisely to switch from 10% to 90% of the total change in current). With this 10–90% step rise time  $t_{10-90}$ , the effective cutoff frequency  $f_c''$  of all filter combinations can be estimated with Eq. 14 (Colquhoun and Sigworth, 1995):

$$f_c'' \approx \frac{0.3396}{t_{10-90}}. \quad (14)$$

The result of this calculation for all filter combinations used in this work is listed in Table 3. The effective cutoff frequency  $f_c''$  calculated with the step rise time was close to the values of  $f_c'$  and  $B_{th}$  at a given filter setting. Alamethicin events can therefore be used to explore the effective bandwidth of a planar bilayer setup up to a bandwidth of at least 10 kHz. Wonderlin et al. (1990) reported that the access resistance  $R_a$  and the capacitance at the headstage input  $C_t$  limited the maximum recording bandwidth achievable in planar bilayer experiments. In the absence of series resistance compensation, the maximum bandwidth can be estimated with Eq. 15 (Levis and Rae, 1998):

$$B \leq \frac{1}{2 \pi C_t R_a}. \quad (15)$$

The access resistance of the Teflon AF septa that had been fabricated using the probe-tip or spin-coating method was very low (Eqs. 2 and 3, respectively); as a result, even without series resistance compensation, the maximum

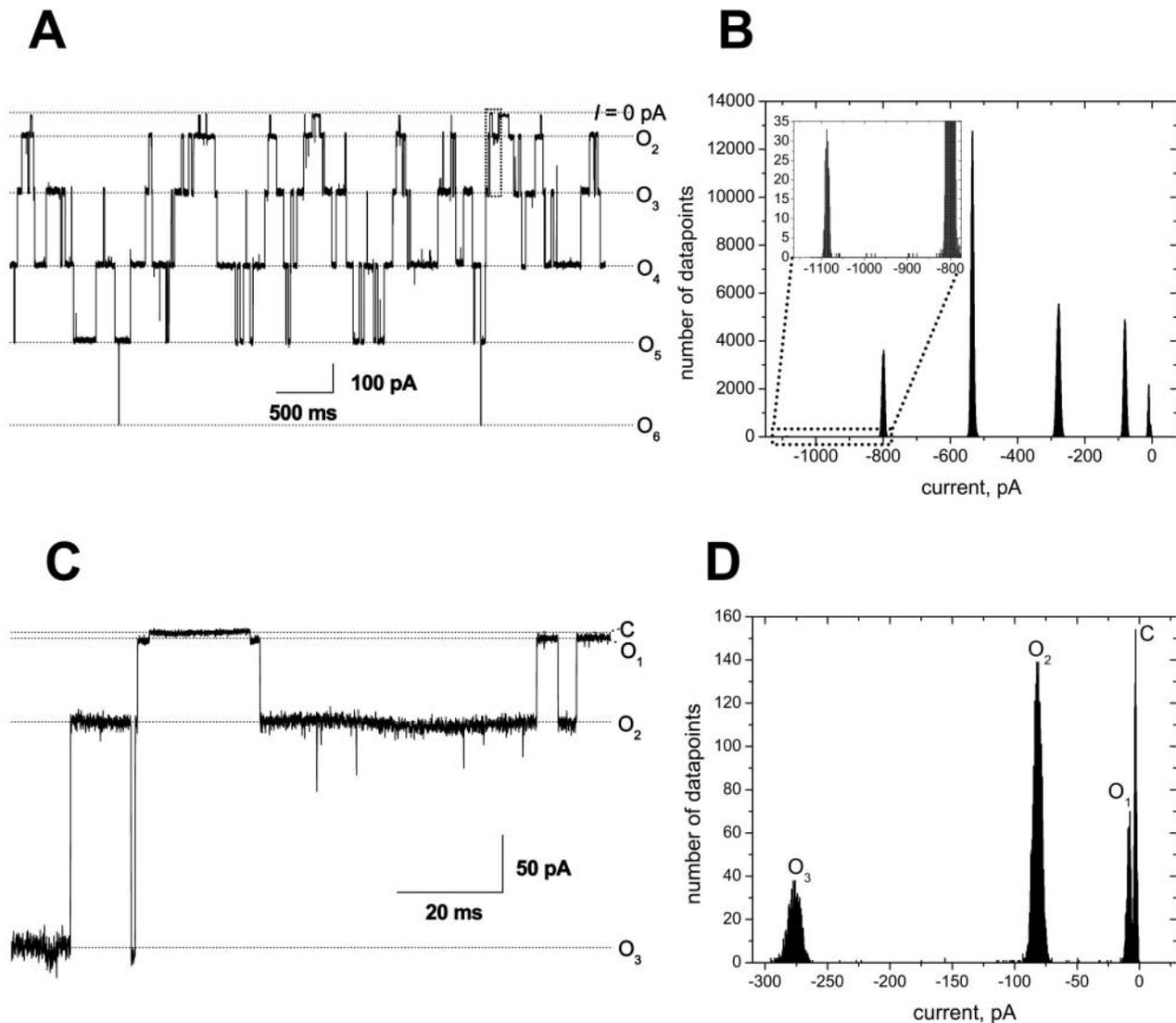


FIGURE 8 Single channel recording of alamethicin events at high effective bandwidth (10.7 kHz) and corresponding point-amplitude histograms of the current trace. (A) Alamethicin channel events recorded at  $-202$  mV. The dotted lines indicate a current  $I = 0$  pA, and the open state current amplitudes  $O_2$ – $O_6$  as revealed by the peak maxima of the histogram. (B) Point-amplitude histogram of the current trace shown in A. (C) Magnified area from the trace shown in A, dotted square). The recording shows the baseline current, C, in the closed state of the alamethicin channel. (D) Corresponding point-amplitude histogram, revealing the open state  $O_1$ . The single-channel conductance values of open states  $O_1$ – $O_6$  are: 24, 395, 1375, 2662, 3989, and 5430 pS. Alamethicin concentration:  $10 \text{ ng mL}^{-1}$  in both chambers; buffer: 1 M KCl. A Teflon AF sheet with a pore diameter of  $15 \mu\text{m}$  was used and the total capacitance  $C_1$  was 36 pF. The filter frequency was 10 kHz ( $B_{\text{th}} = 10650$  Hz) and the sampling frequency was 50 kHz.

bandwidth as calculated with Eq. 15 was at least 30 kHz. Therefore, in the work presented here, the effective recording bandwidth was never limited by the product  $C_1 \times R_a$  but by

**TABLE 3** Ten–90% step rise time analysis of alamethicin events obtained with different overall cutoff frequencies  $f_c'$

$f_c'$ (Hz)	$B_{\text{th}}$ (Hz)	$t_{10-90}$ ( $\mu\text{s}$ )	$f_c''$ (Hz)
971	1034	335.2	1013
4082	4347	76.2	4457
7071	7531	44.5	7631
10000	10650	28.5	11916

We listed the effective cutoff frequency  $f_c''$  that was calculated with Eq. 14.

the filter settings of the low-pass filter that were chosen for the recording.

Table 3 also shows that it does not take *longer* than 28.5  $\mu\text{s}$  for alamethicin to switch from one conductance state to the next; the real transition time is, however, presumably considerably shorter.

## CONCLUSION

By preparing planar lipid bilayers over pores with varying diameters, we found that above pore diameters of  $40 \mu\text{m}$ , the current noise increased strongly with increasing pore

diameter and bandwidth as predicted by theory. The main sources of noise were i), the thermal voltage noise of the access resistance in series with the bilayer capacitance,  $i_{rc}$ ; ii), the noise resulting from the interaction of the headstage input voltage noise and the input capacitance,  $i_{vc}$ ; and iii), in the case of septa made of Teflon AF, to a smaller extent the dielectric noise,  $i_d$ . The noise recorded with bilayers on pores with a diameter smaller than 40  $\mu\text{m}$ , however, was dominated by additional sources of noise, which were summarized as excess noise,  $i_e$ . Possible contributions to  $i_e$  are shot noise, seal noise, flicker noise ( $1/f$  noise), electrode noise, and noise from external sources (Sherman-Gold, 1993). The excess noise  $i_e$  was proportional to the total input capacitance  $C_t$ . For small pore diameters ( $<15 \mu\text{m}$ ),  $C_t$  was dominated by the capacitance of the Teflon film and the electrodes; consequently, a further reduction of the pore diameter would have only a small effect on the current noise. To approach the low-noise characteristics of patch clamp recordings with planar lipid bilayer experiments, the capacitance of the bilayer setup (electrodes, electrode holder, Teflon film) would have to be reduced to a total value of  $\leq 2 \text{ pF}$ .

Although the noise levels obtained with Teflon AF films were higher than the levels of patch clamp experiments, they were extremely low in the context of planar bilayer experiments. Pores with diameters  $\leq 40 \mu\text{m}$  allowed planar bilayer recordings with a current noise  $\leq 0.4 \text{ pA rms}$  at a bandwidth of 4.3 kHz and supported bilayers that were stable at voltages up to 460 mV. The low access resistance of the tapered pores afforded recordings with fast time resolution (effective bandwidth  $\geq 10.7 \text{ kHz}$ ).

Recently the interest in employing electrophysiological techniques for high-throughput screening is increasing (Denyer et al., 1998; Fertig et al., 2002; Schmidt et al., 2000; Xu et al., 2001). Performing recordings from multiple planar lipid bilayers in parallel would be an attractive approach. In a first step toward this goal, we showed here that Teflon AF films with multiple microfabricated pores could be used for the stable formation of multiple lipid bilayers at defined locations in the supporting film.

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